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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of: Michael (Miguel) Anthony Molina, Sr., Michael Anthony Molina, II and Joseph Albert Ojeda, Sr.

Serial No.: 10/666,649 Filed: September 19, 2003

Group: To Be Assigned Examiner: To Be Assigned

For: COMPUTER CONTROLLED DE-CLIP-SHADOW MASK REMOVAL MACHINE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:

9/14/04

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Gregory M. Howison

(Name of Person Mailing Document)

9/14/04

(Signature)

9/14/04

(Date of Signature)

RESPONSE TO RESTRICTION REQUIREMENT

In response to the Restriction Requirement dated August 26, 2004, in the above-captioned patent application, the Examiner identified two (2) groups of claims, Group I, Claims 11-20, drawn to a semiconductor device and Group II, Claims 1-10, drawn to process of making a semiconductor device. Applicants elect the claims in Group II, the Claims 1-10, drawn to process of making a semiconductor device without traverse.

Respectfully submitted,  
HOWISON & ARNOTT, L.L.P.

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September 13, 2004

AMENDMENT AND RESPONSE  
S/N 10/666,649  
Atty. Dkt. No. MOLI-26,465